

Three way meeting between ESRF, APS and SPring-8
“Time-resolved science and technique”

**Time-resolved x-ray SR experiments
using synchronized femtosecond pulsed laser
in SPring-8**

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**RIKEN/SPring-8 Center
JASRI/SPring-8
CREST, JST**



--- Outline ---

1. Introduction

- 1.1. Typical time scales of phenomena with atomic motion
- 1.2. Time structure of SR sources
- 1.3. TR technique and synchronization

2. Key technology for Laser-SR synchronization

- 2.1. Precise timing (phase) control
- 2.2. Repetition rate

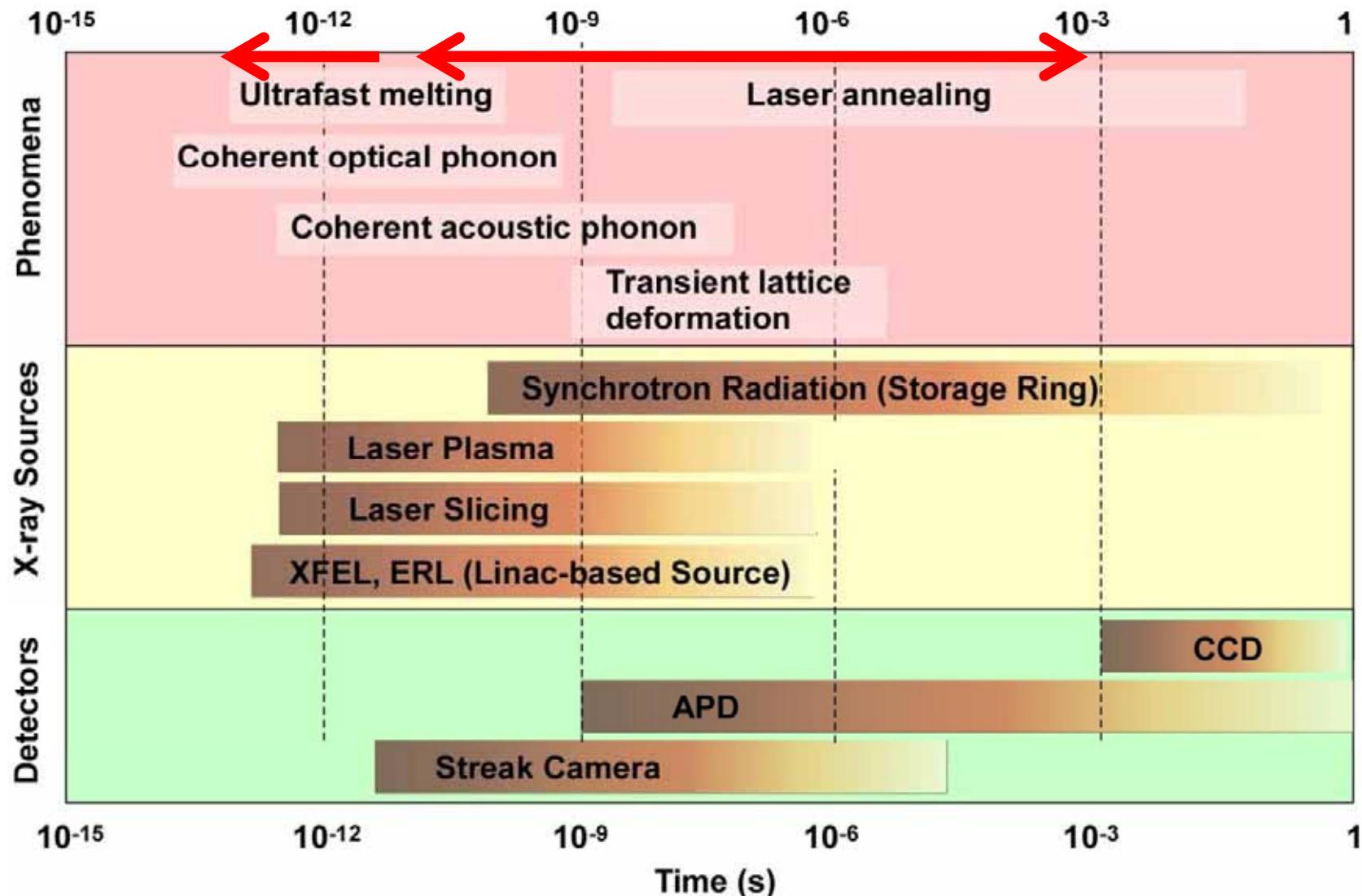
3. Experiments

- 3.1. Acoustic pulse echo
- 3.2. Amorphous-crystal phase transition
- 3.3. Laser seeding in FEL

4. Summary and Prospective

1. Introduction

1.1. Typical time scales of phenomena



1.2. SR sources & the time structure

1. Storage ring SR sources

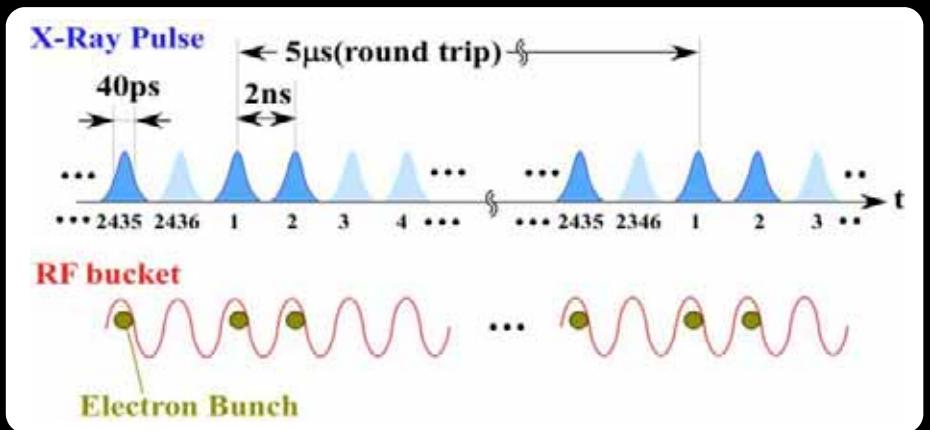


SPring-8

APS

ESRF

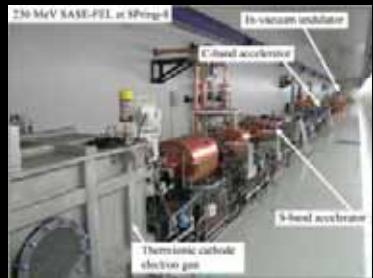
Pulse width:
40 ps (FWHM)
Rep. rate:
200 kHz-509MHz



2. Linac-based SR sources (FEL)



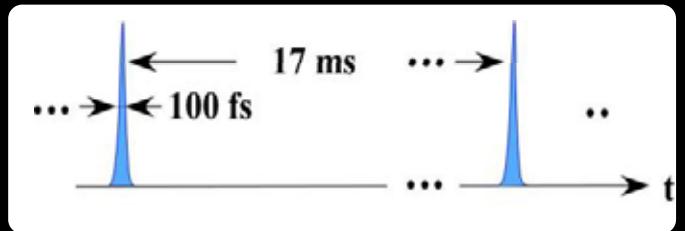
SLAC LCLS



SCSS

EuroFEL

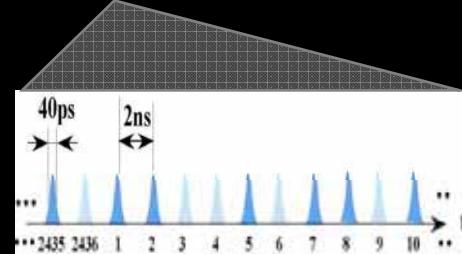
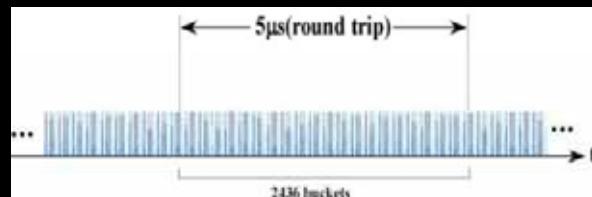
<<100 fs
60 Hz (FEL)



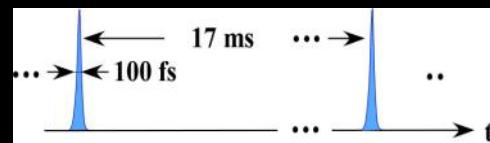
1.3. TR techniques at SPring-8

SR time structure

Storage Ring



FEL



Time resolution & Method

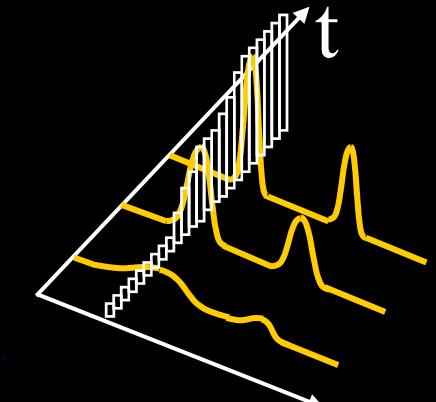
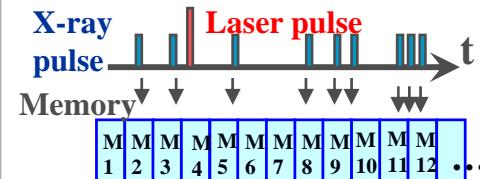
1 ms

1 μs

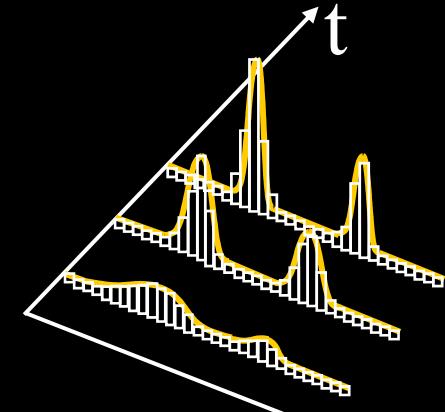
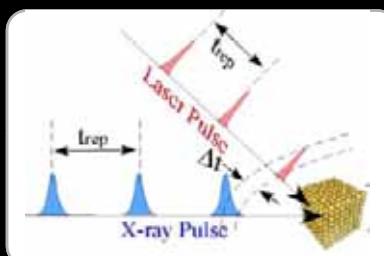
1 ns

1 ps

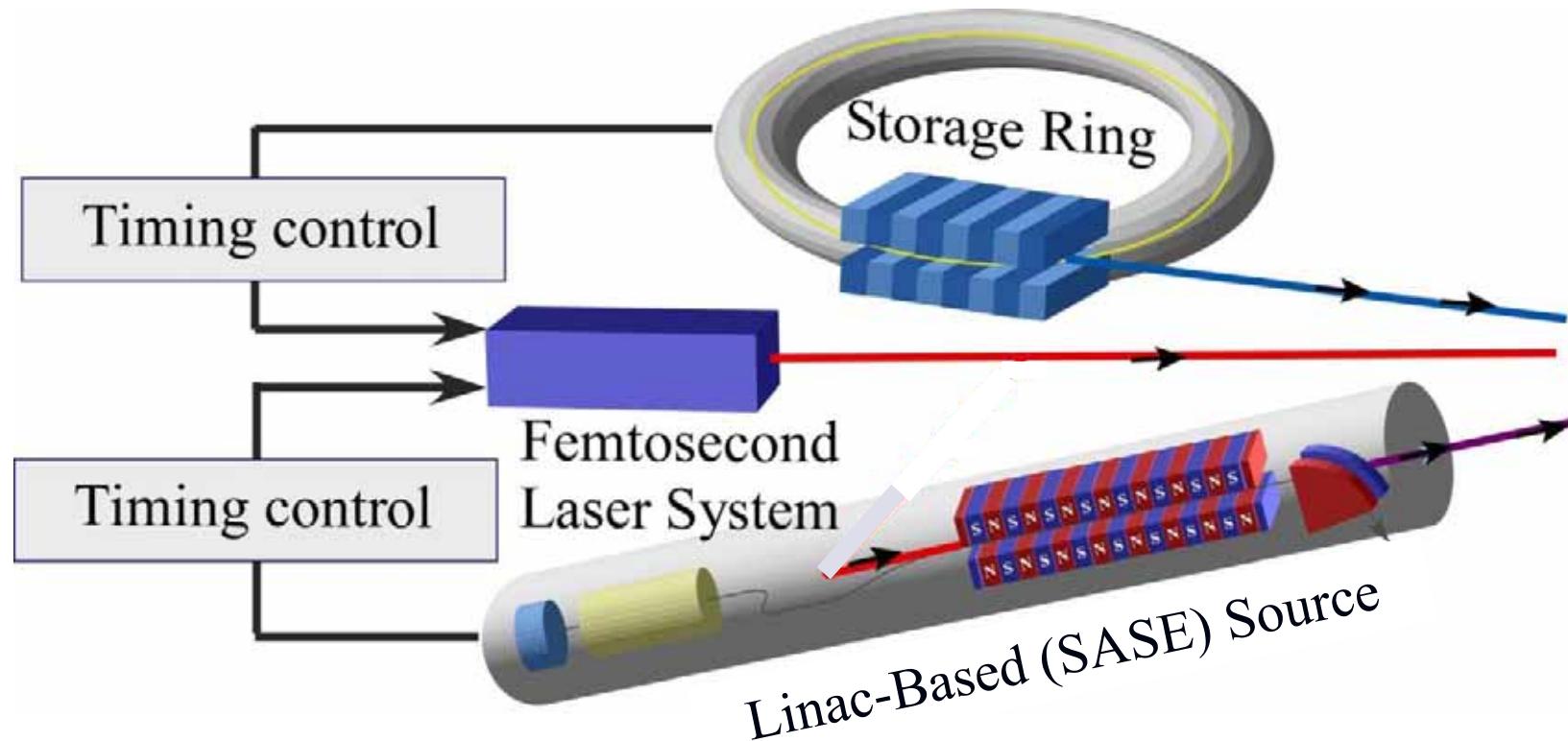
APD+MCS



Pump-probe



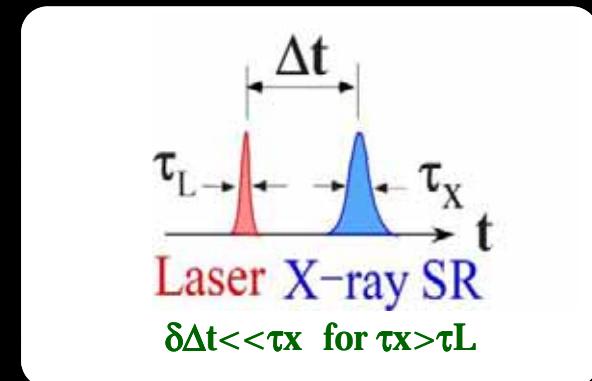
SR-laser synchronization



2. Key technology for SR-laser synchronization

2.1 Precise timing (phase) control

- Required precision
 << Pulse width
 40 ps for Ring
 100 fs for Linac

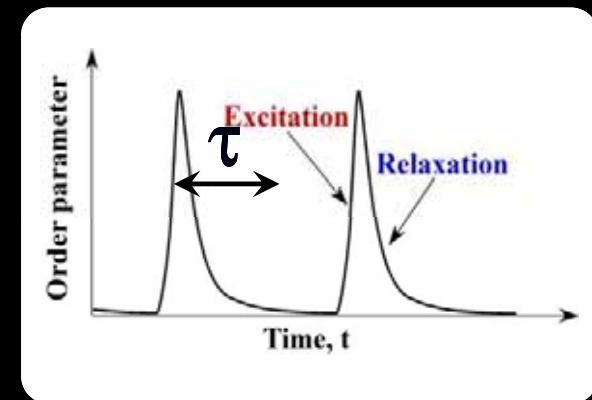


2.2 Repetition rate issue

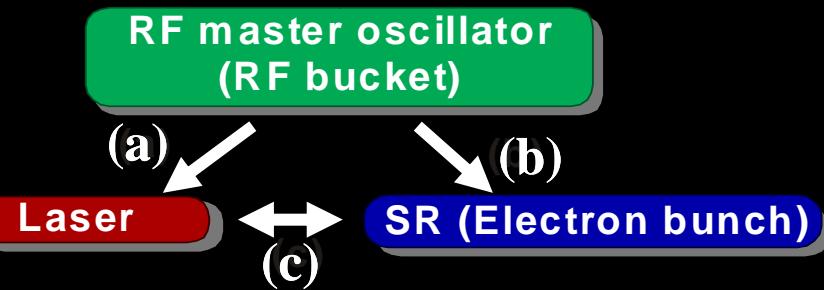
- Dependent on recovery time
 in target phenomenon

$$1/f_{rep} > \tau \quad \sim 1 \text{ ms}$$

- Available averaged power of
 the pulsed laser



2.1 Precise timing (phase) control at storage ring



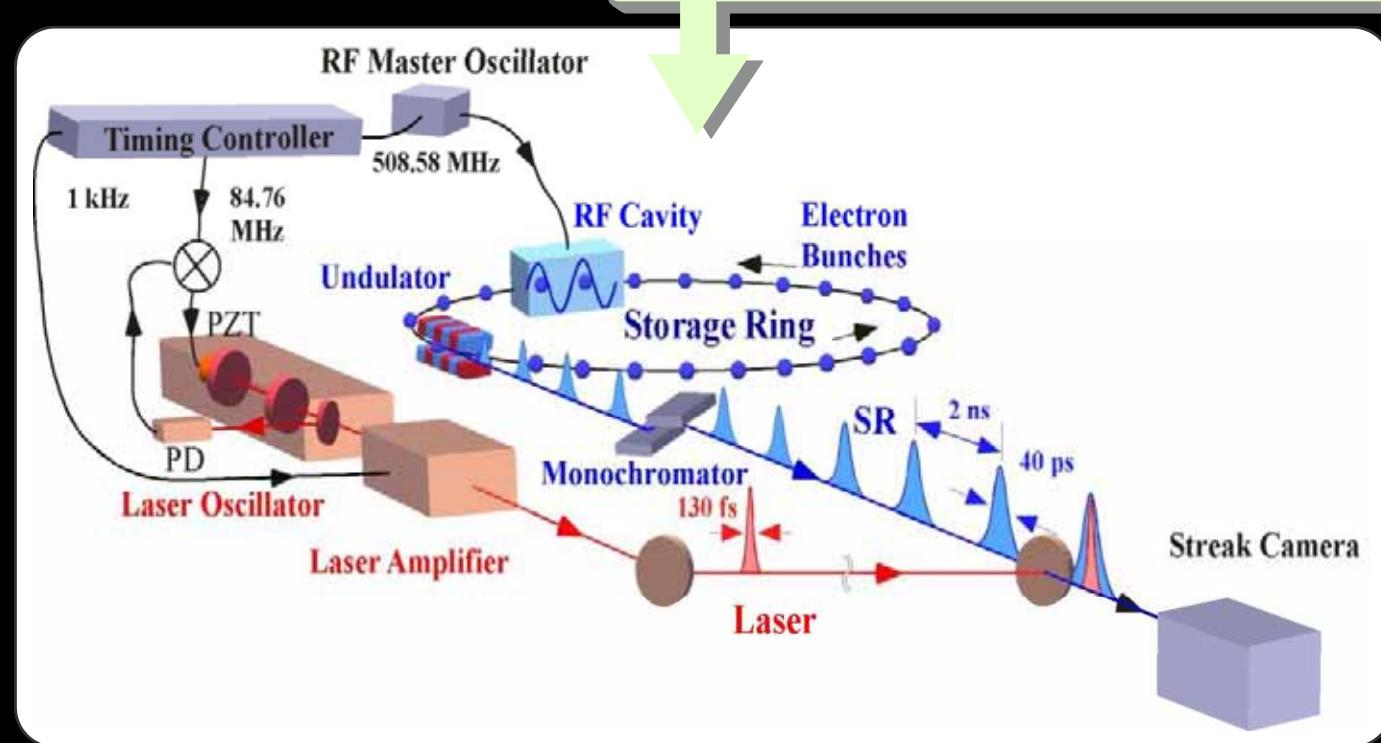
Synchronization scheme

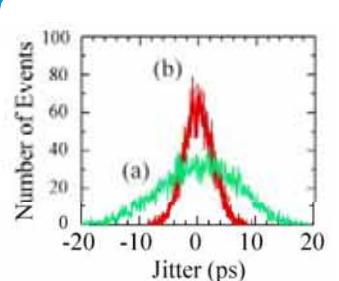
- Mode-locked Ti:sapphire laser with external trigger from a RF master oscillator of the ring

$$\text{Cavity length} = \frac{1}{2} \cdot \frac{c}{(f_0/6)}, \quad f_0: \text{Frequency of RF master oscillator}$$

- Output timing of amplified laser pulses is controlled with a counter and a delay pulse generator

$$(\text{Repetition rate} = \frac{1}{2436 \times 209} f_0 \sim 1 \text{ kHz})$$





RF master oscillator (RF bucket)

$\Delta t_{\text{jitter}} < 3 \text{ ps}$

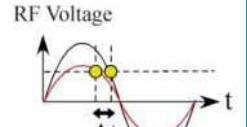
$\Delta t < 5 \text{ ps}$

$\Delta t_{\text{drif}} < 5 \text{ ps}$

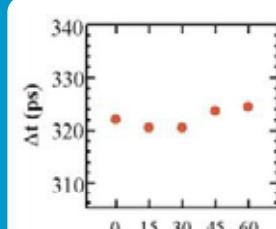
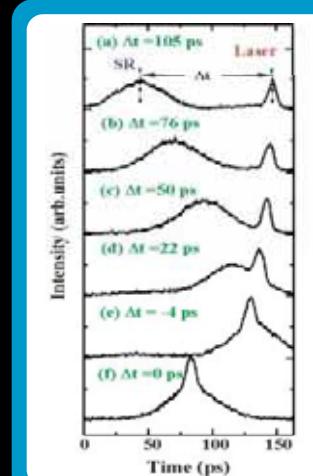
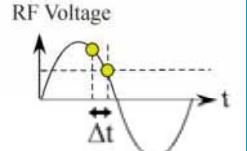
Laser

SR (Electron bunch)

- Beam loading effect



- Electron energy loss



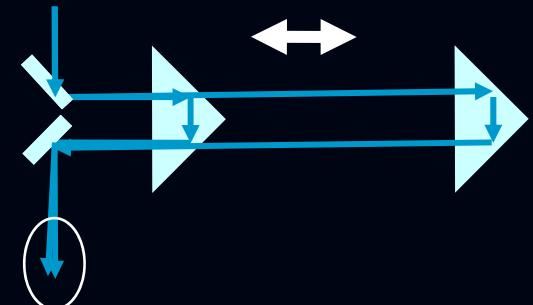
Long-term stability
 $< \pm 2 \text{ ps}$

$\Delta t < 5 \text{ ps}$

Time(phase)-delay control

1. Optical Delay

- High precision delay
- Large delay may cause the misalignment at a sample



2. RF trigger delay (Continuous phase shifter)

- Compact, Quick feedback

$$E(t) = \sin \omega t$$

$$A_1 \cos \omega t + A_2 \sin \omega t = \sin(\omega t - \alpha) = \sin(\omega(t-\tau)) = E(t-\tau)$$

\nwarrow Phase $\alpha > 2\pi$ \nearrow Time delay

$A_1 = -\sin \alpha, \quad A_2 = \cos \alpha$

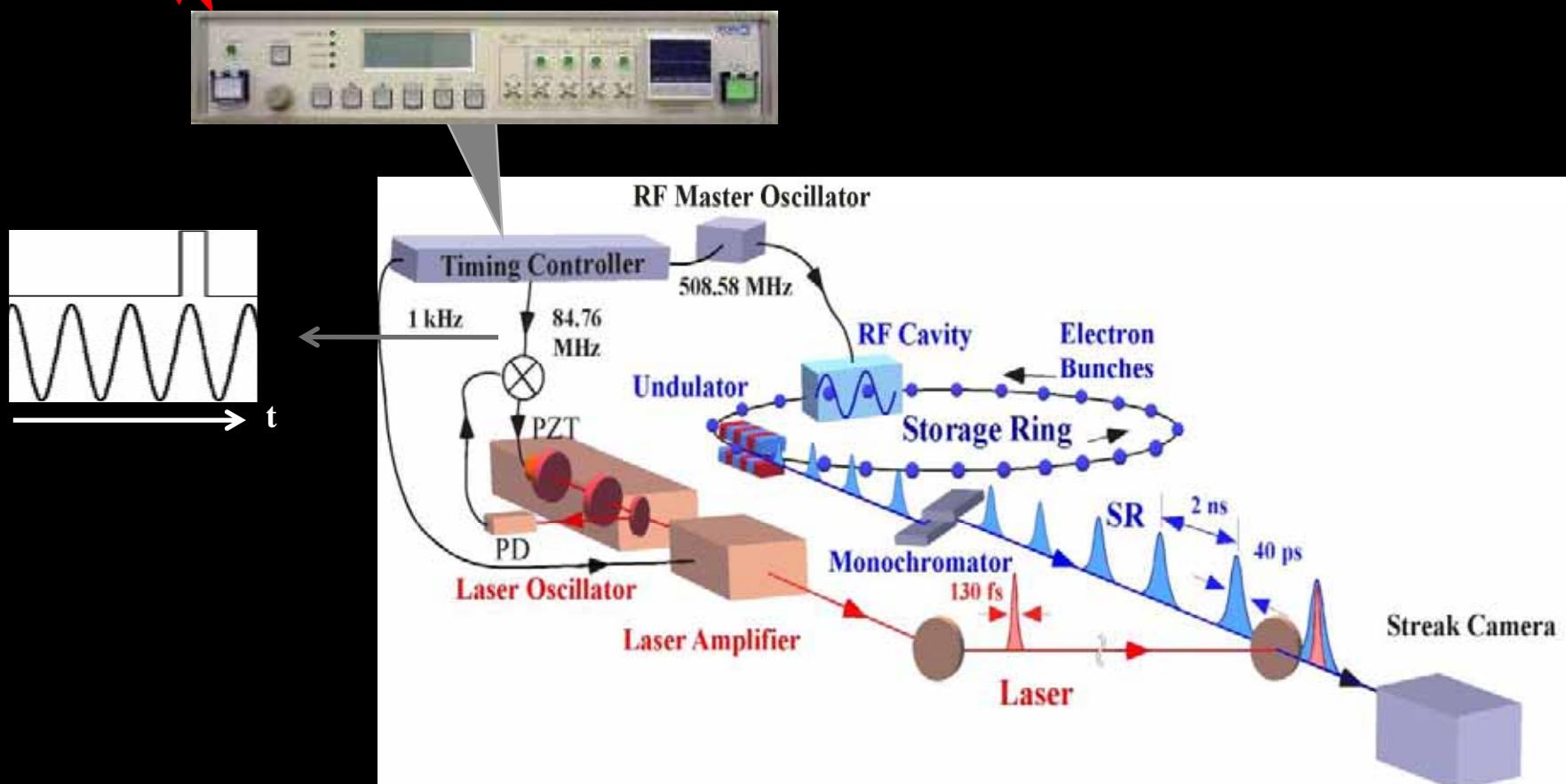
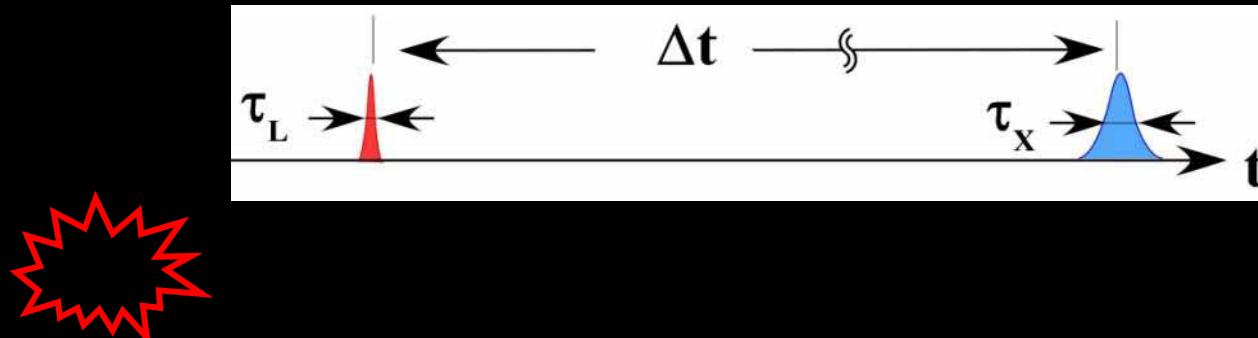


T. Ohshima, Y. Tanaka: Patent No. TOKUGAN2006-067346



Codox co.

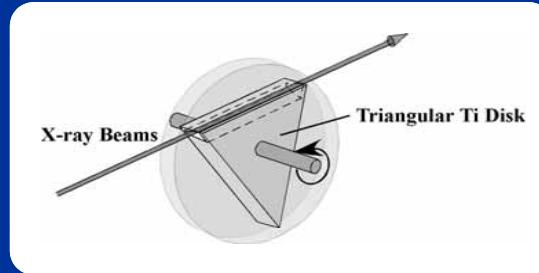
Wide range with 5 ps precision timing control



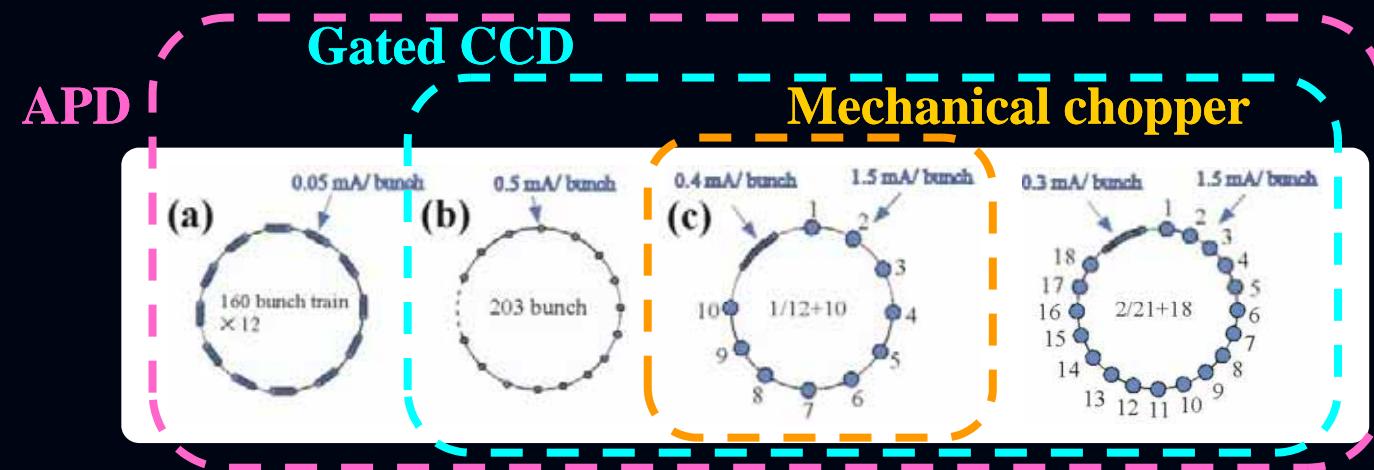
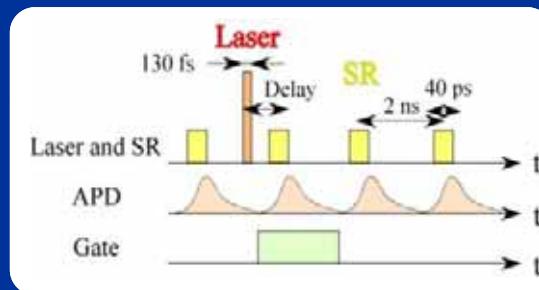
2.2 Repetition rate

Extraction of X-ray pulses with low rep. rate

(a) Pulse selection by mechanical chopper
Gate > 400 ns

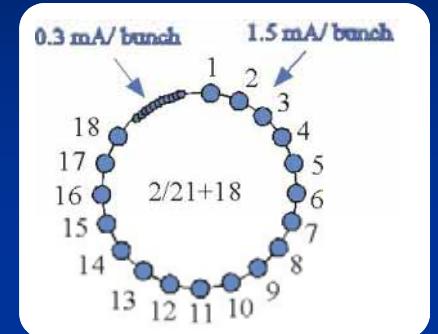
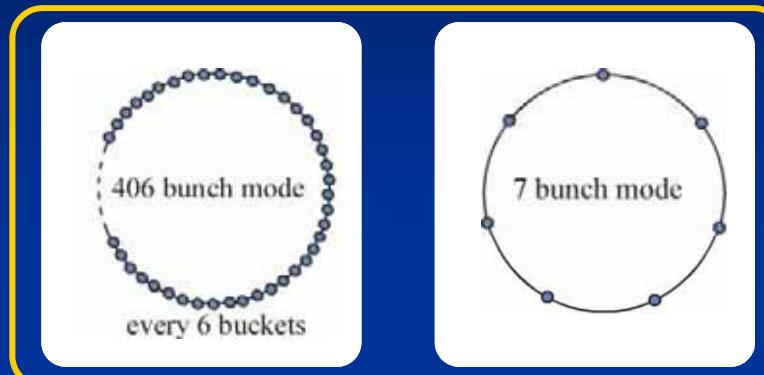


(b) Electronic gate
· Avalanche photodiode
Gate > 5 ns
· Gated X-ray CCD camera
Gate > 100 ns



Pump & probe with high repetition rate (MHz) (Fast decay phenomena by using focused beams)

SR



Laser



Ti:S Oscillator

Regenerative Amplifier

AO modulator

Regenerative Amplifier

$\lambda = 800\text{nm}$
 $\tau = 80\text{fs}$
 $E = 10\text{nJ/pulse}$
 $f = 85\text{ MHz}$

$f = 1\text{ MHz}$

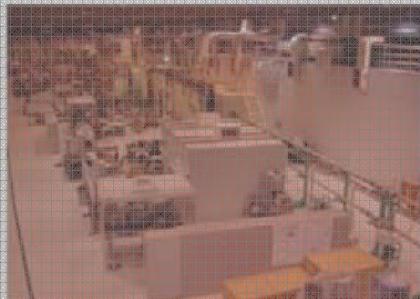
$\lambda = 800\text{nm}$
 $\lambda = 400\text{nm (SHG)}$
 $\lambda = 266\text{nm (THG)}$
 $\tau = 130\text{fs}$
 $E = 1\text{mJ/pulse}$
 $f = 1\text{ kHz}$

+X ray pulse selector

Synchronized femtosecond pulsed laser systems in SPring-8

① BL29XUL

1km-long beamline



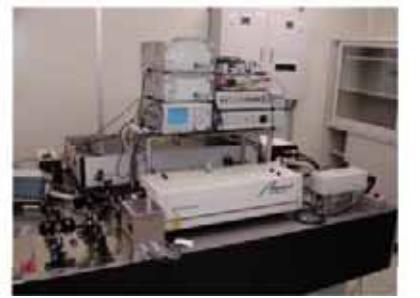
② BL19LXU

27m-long undulator Soft x-ray beamline



③ BL17SU

Soft x-ray beamline



④ BL40XU

CREST hutch



SCSS(FEL prototype accelerator)



⑤

BL25SU

⋮
⋮
⋮

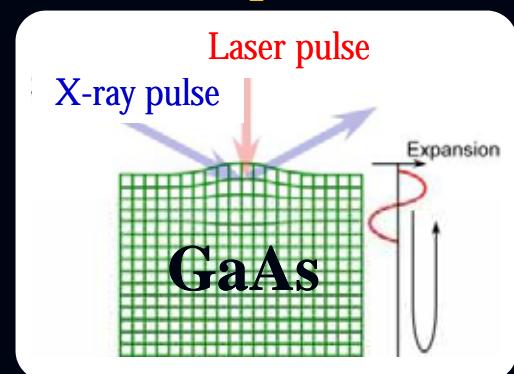
3. Experiments with TR technique with fs lasers

Acoustic echo
in semiconductors

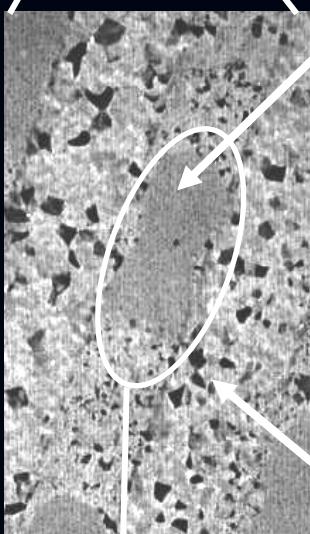
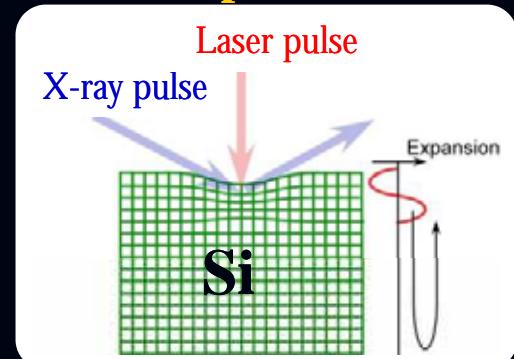
Phase change
in DVD media

Laser seeding
in FEL

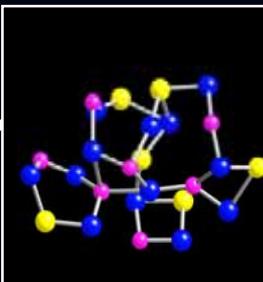
Expansion



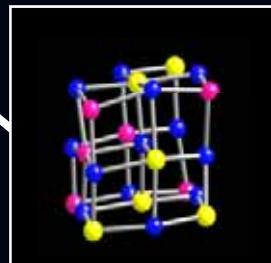
0.1 ps - ns ?
Compression



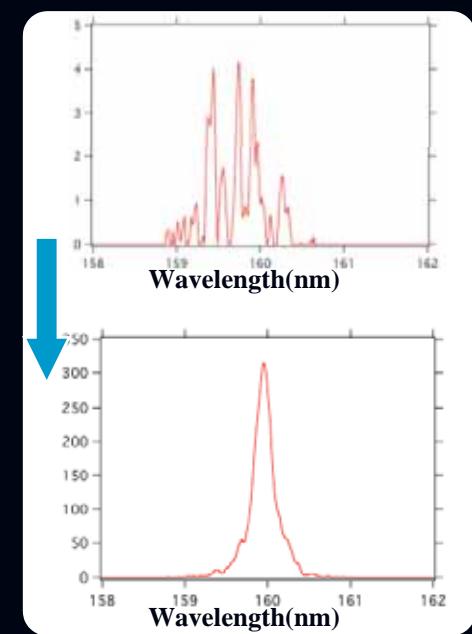
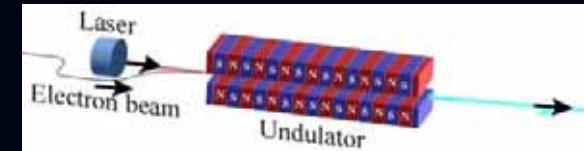
Recorded
mark



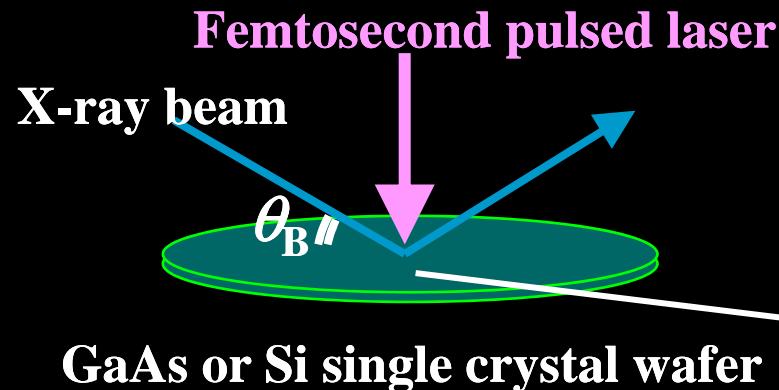
Amorphous
20-30 ns ?



Crystal

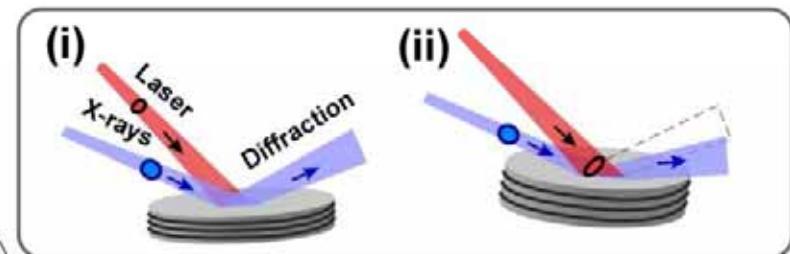
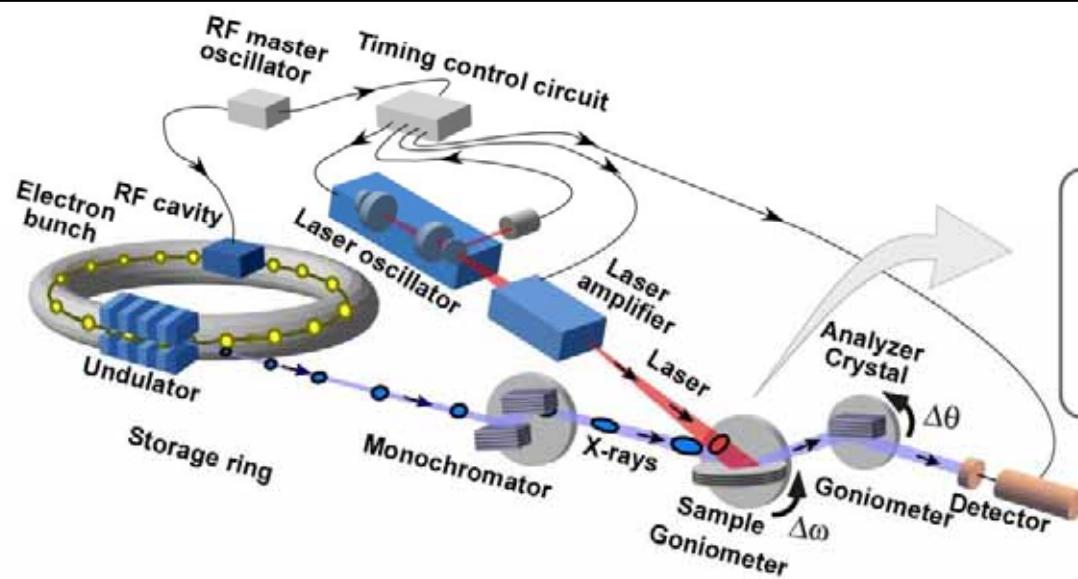
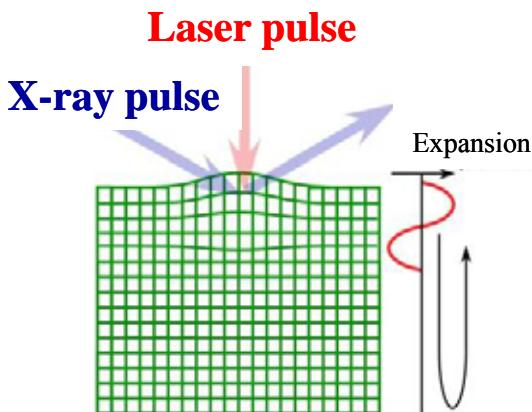


3.1 Acoustic echoes in semiconductors



$\lambda=2d \sin \theta_B$: Bragg condition

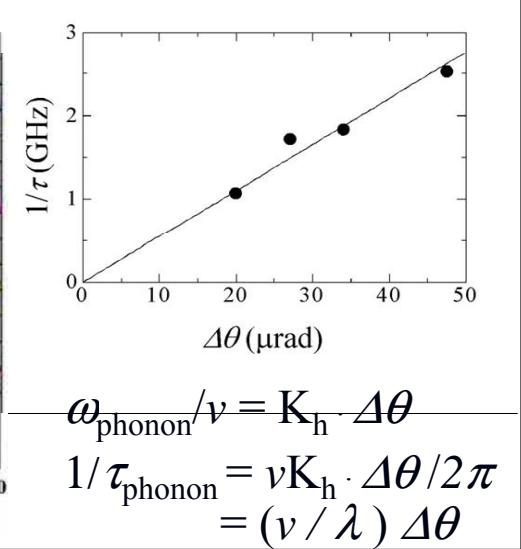
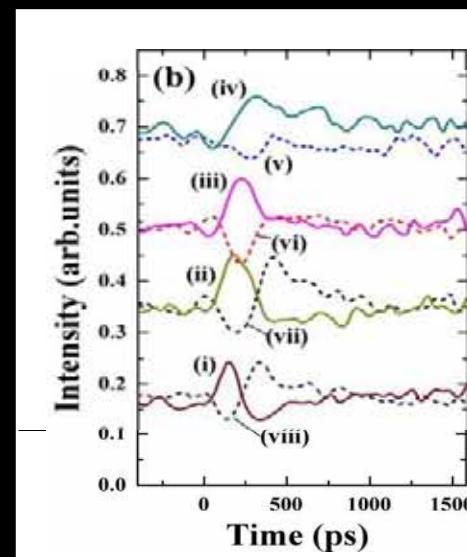
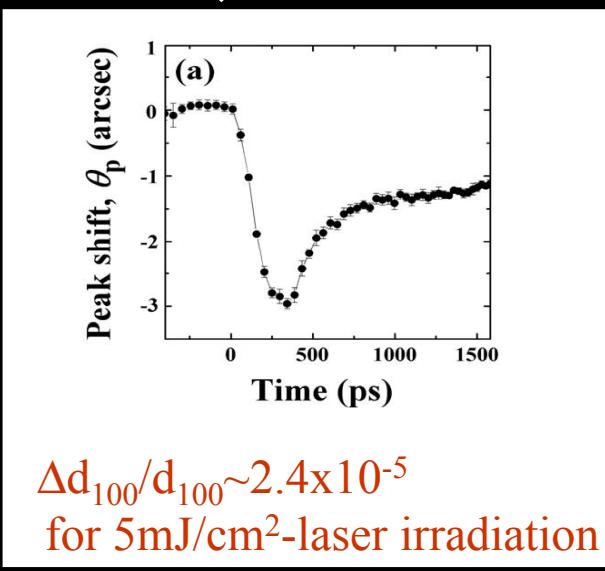
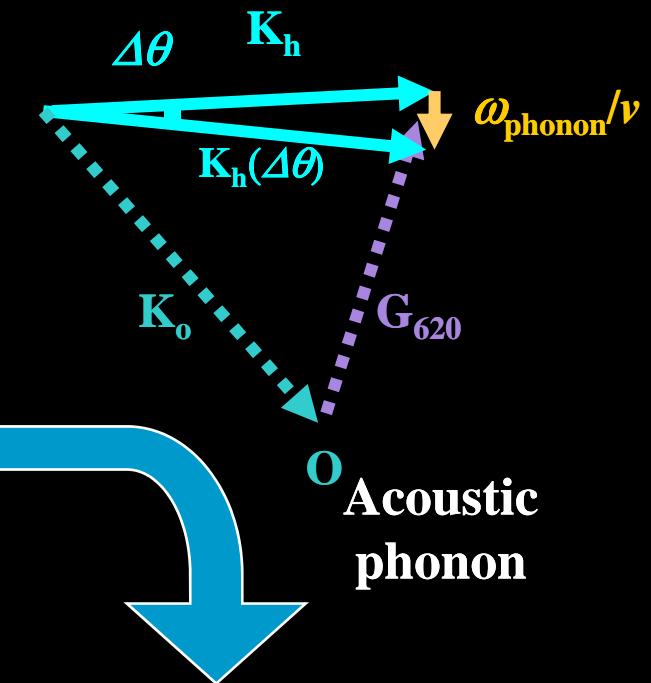
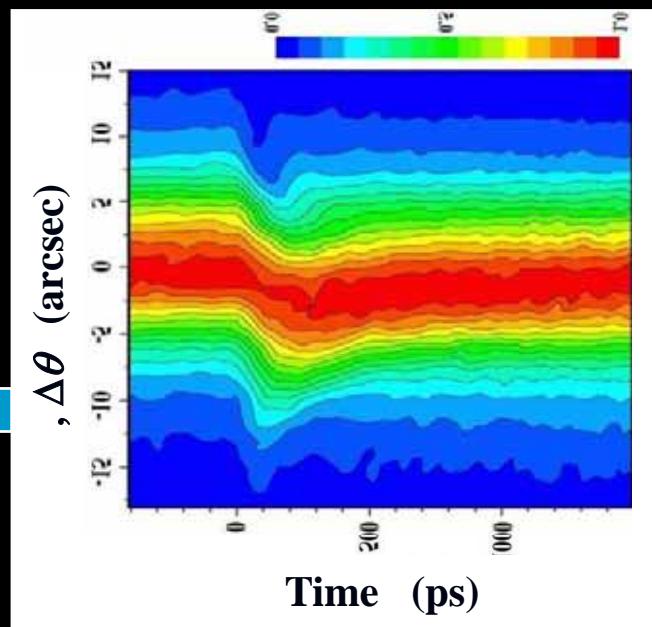
$$\Delta\theta = -(\Delta d/d) \tan \theta_B$$



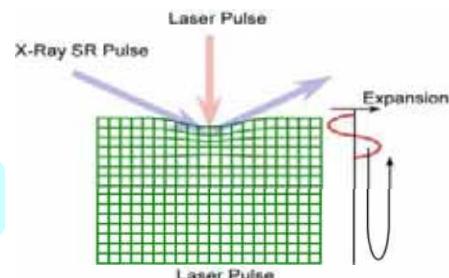
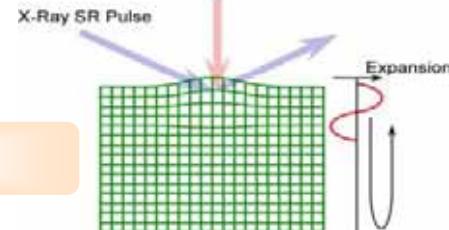
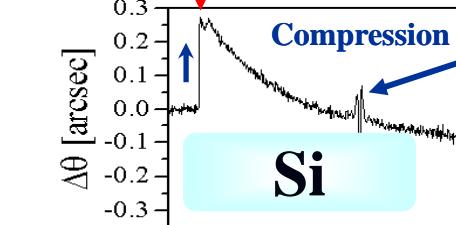
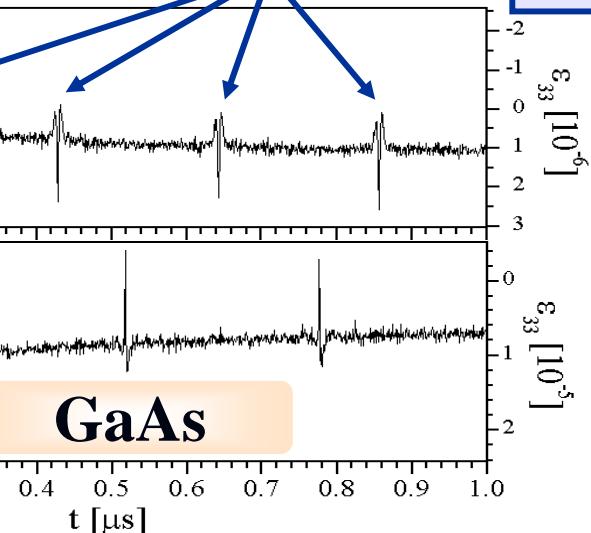
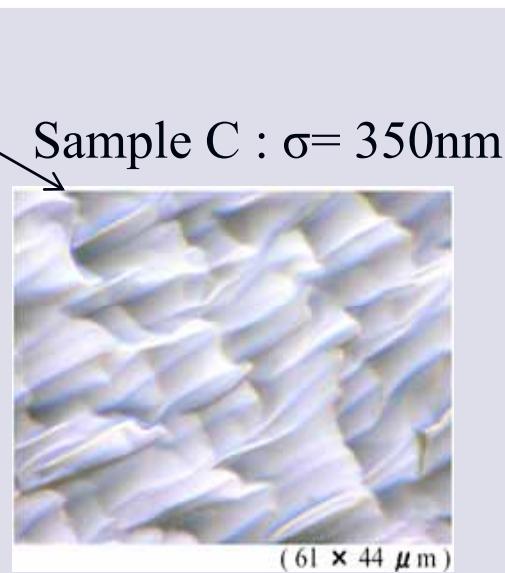
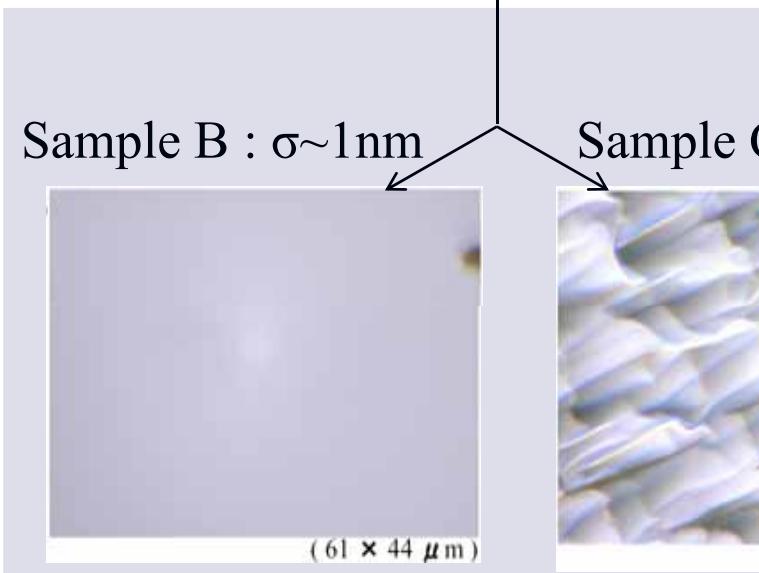
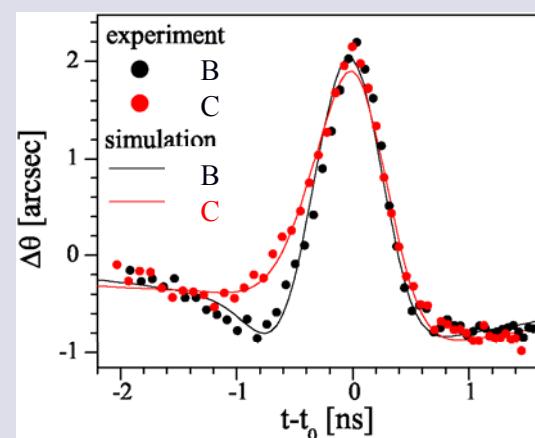
Fast lattice response by fs laser irradiation

GaAs
 $\langle 100 \rangle$

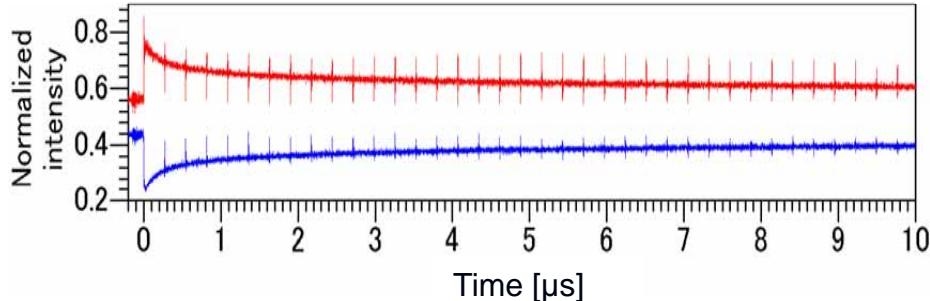
Lattice
 expansion



Pulse echoes in Si and GaAs

Si**GaAs****Laser irradiation****Echo pulse****MCS****Pump-probe**

Wide range with high resolution measurements



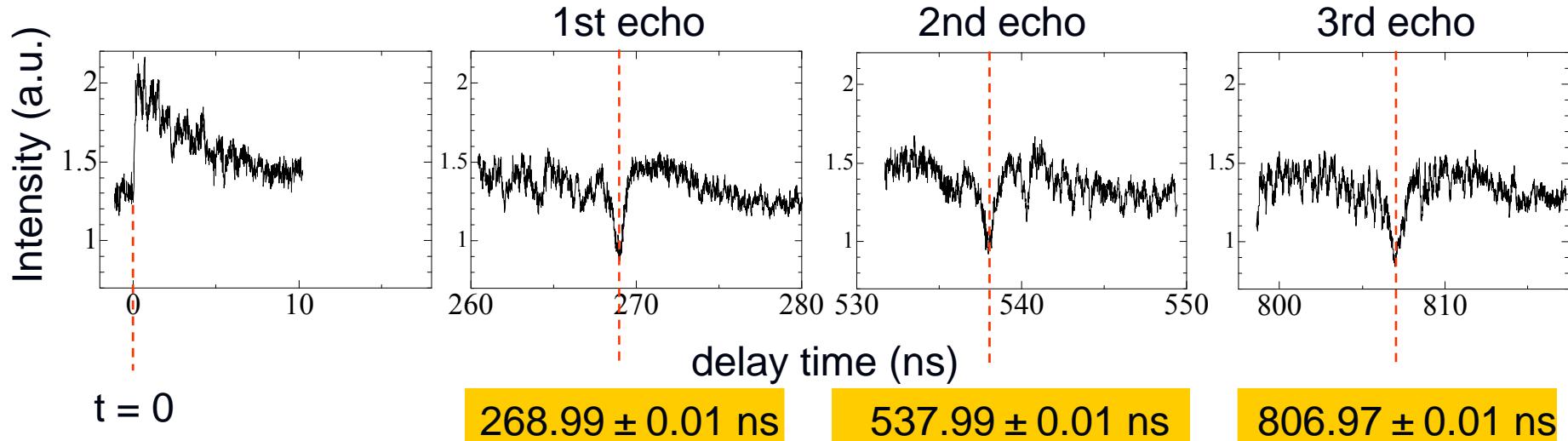
Acoustic pulse echoes measured with MCS

Pump-probe with wide time range



Scan range: 0 ~ 820 ns

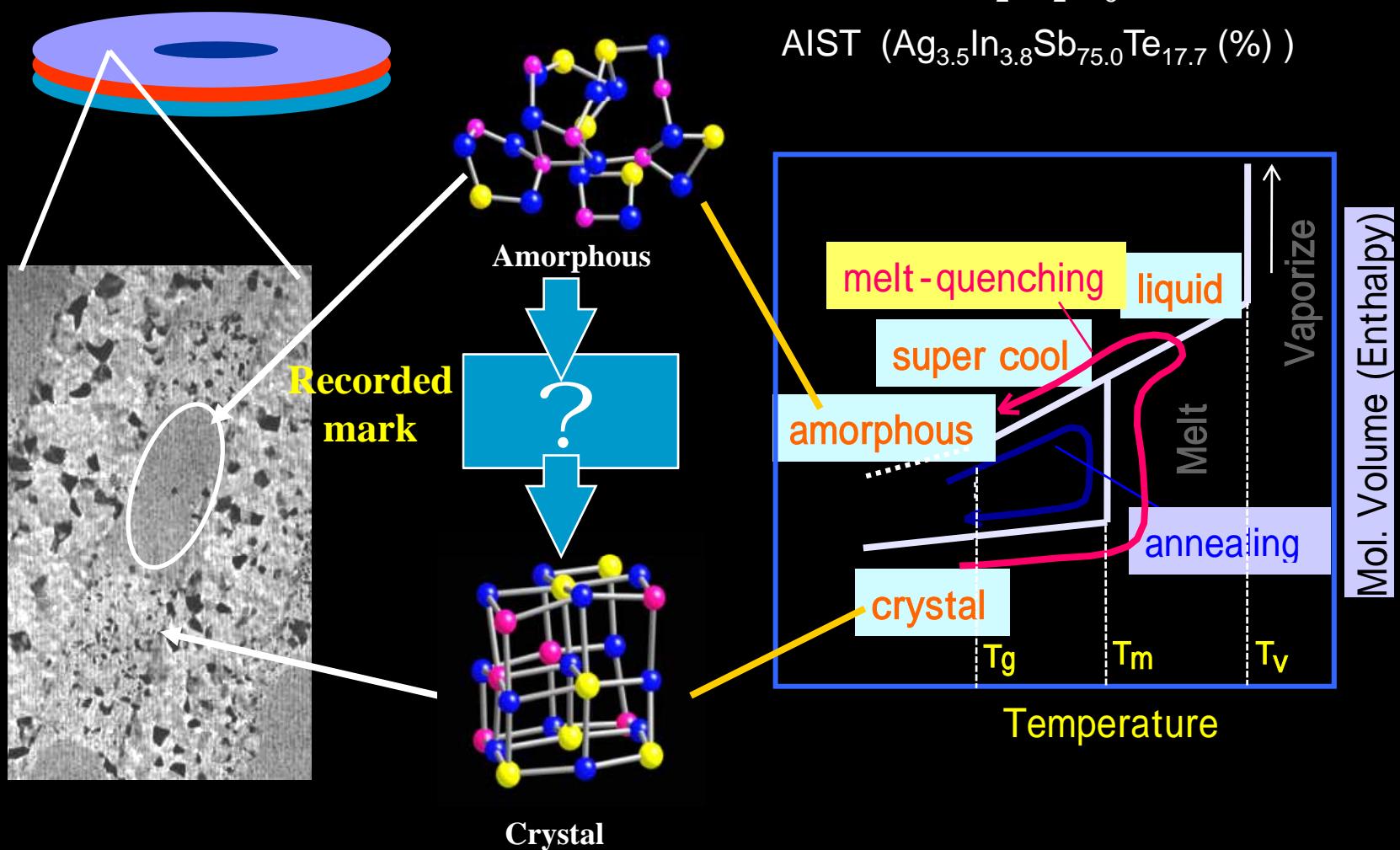
Scan step: 10 ps



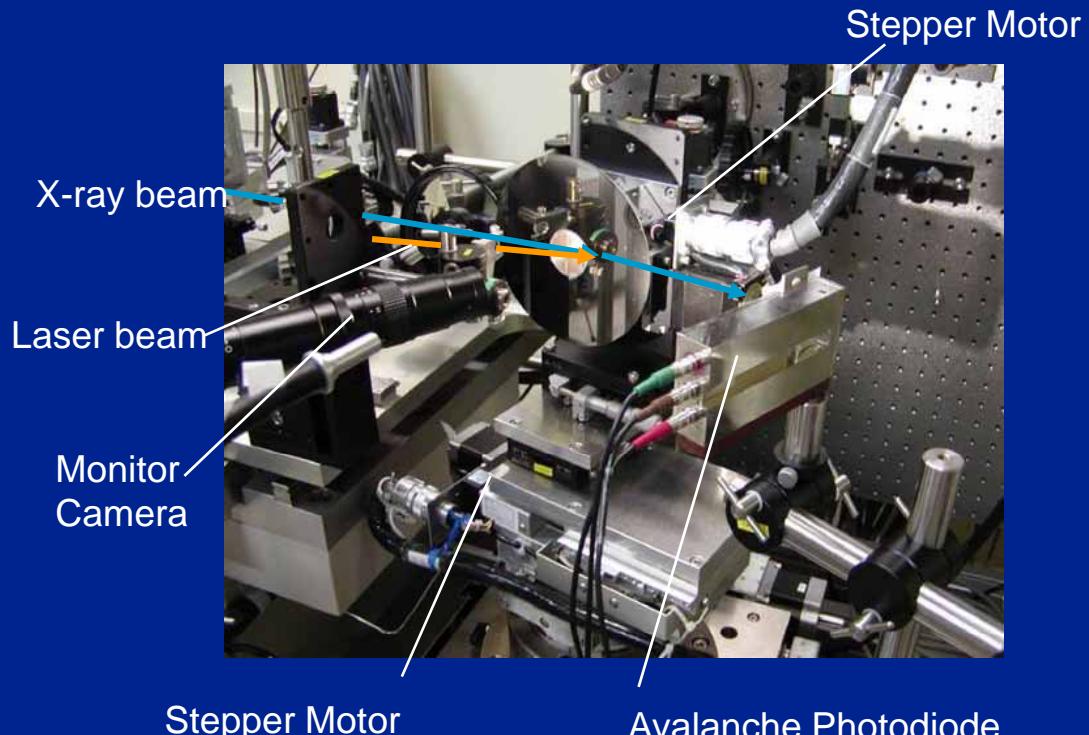
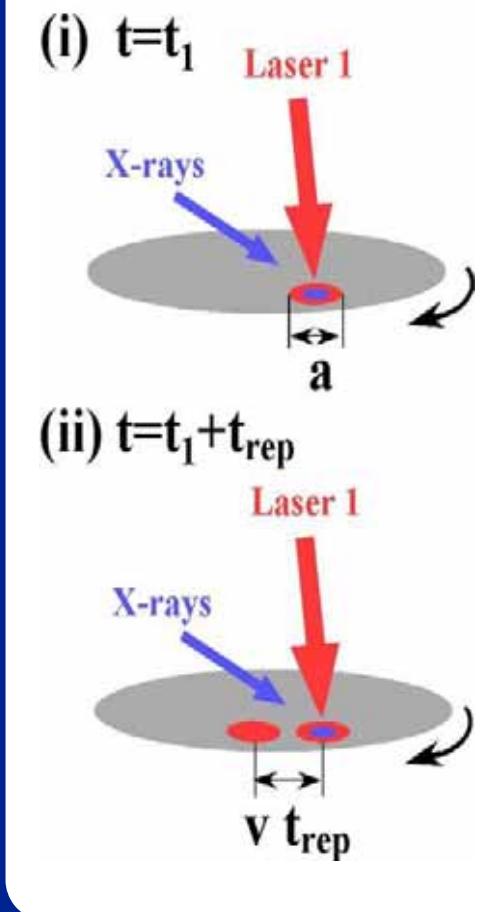
$$\downarrow v = L / \Delta t$$

High precision measurement of sound velocity

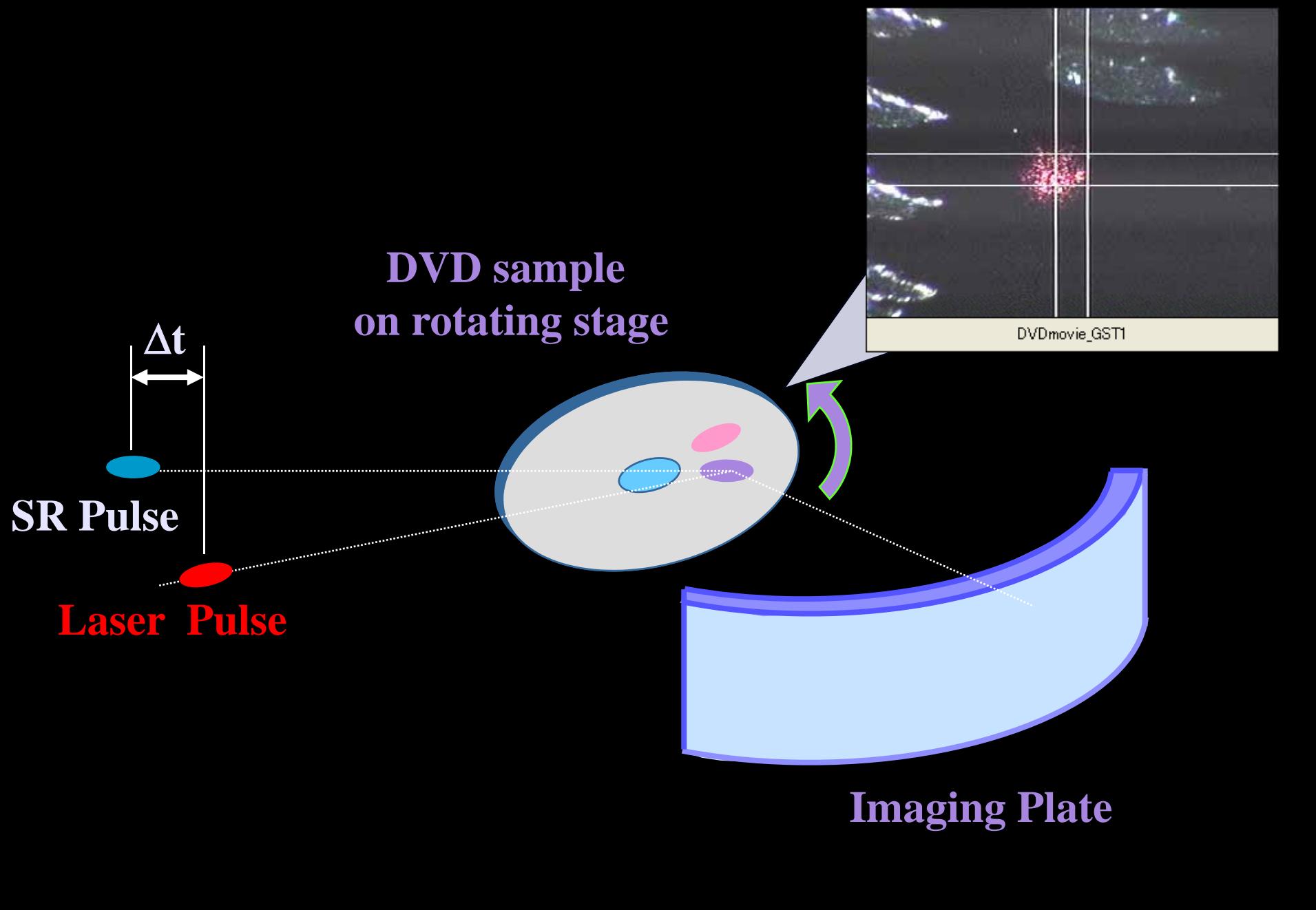
3.2. TR-measurement for amorphous-crystal phase change in DVD media



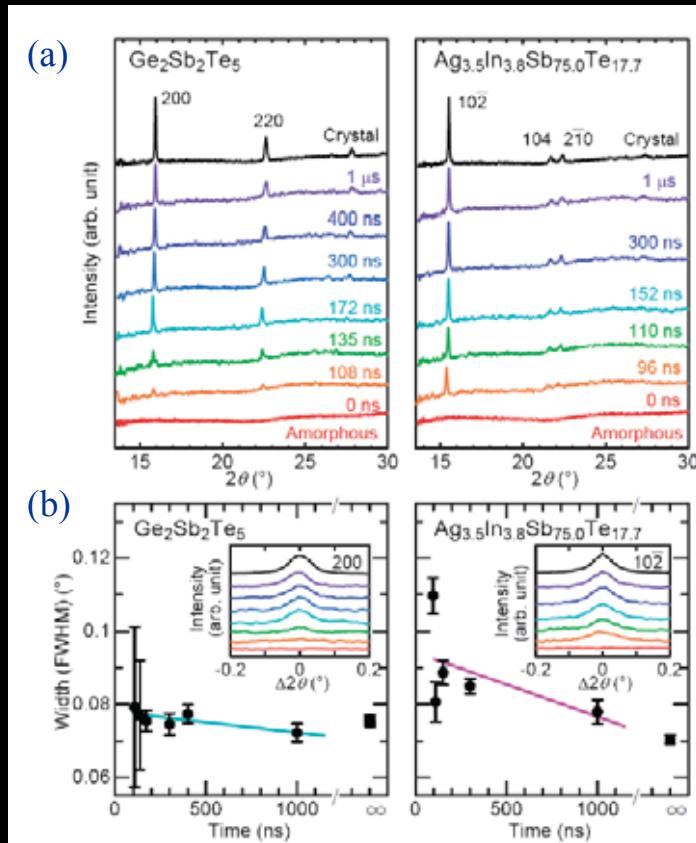
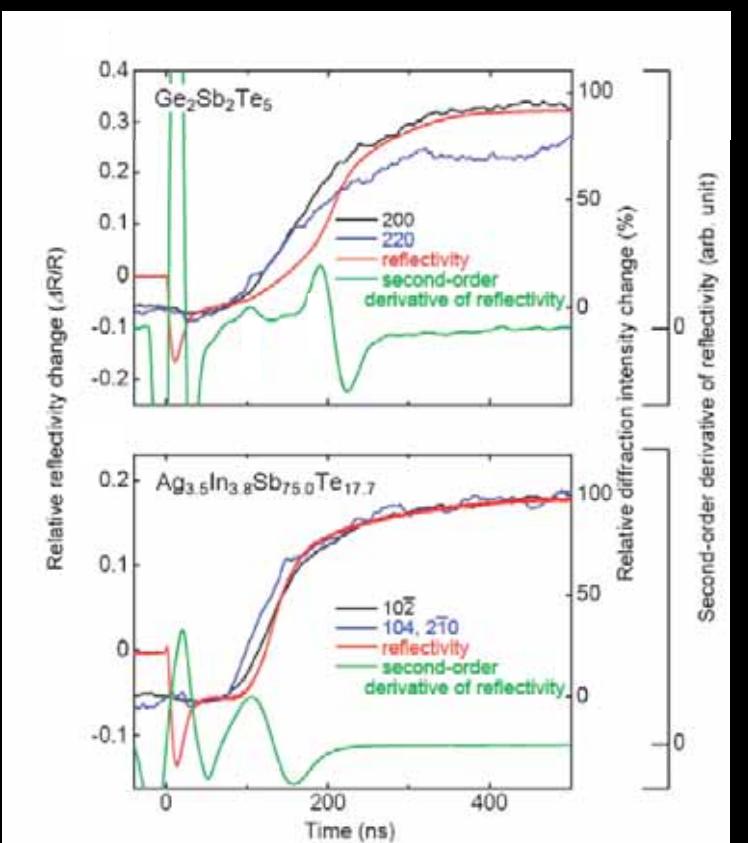
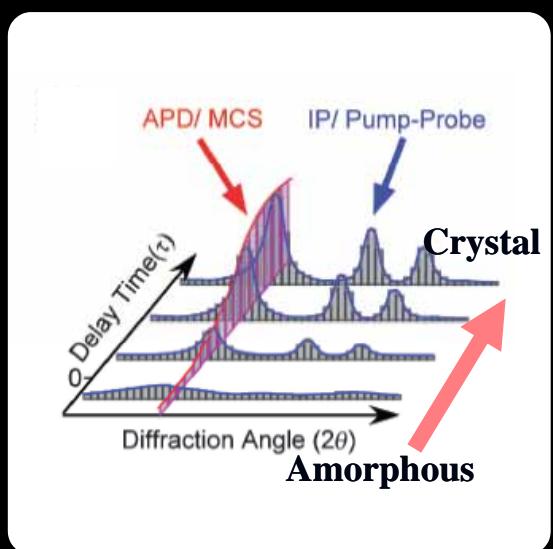
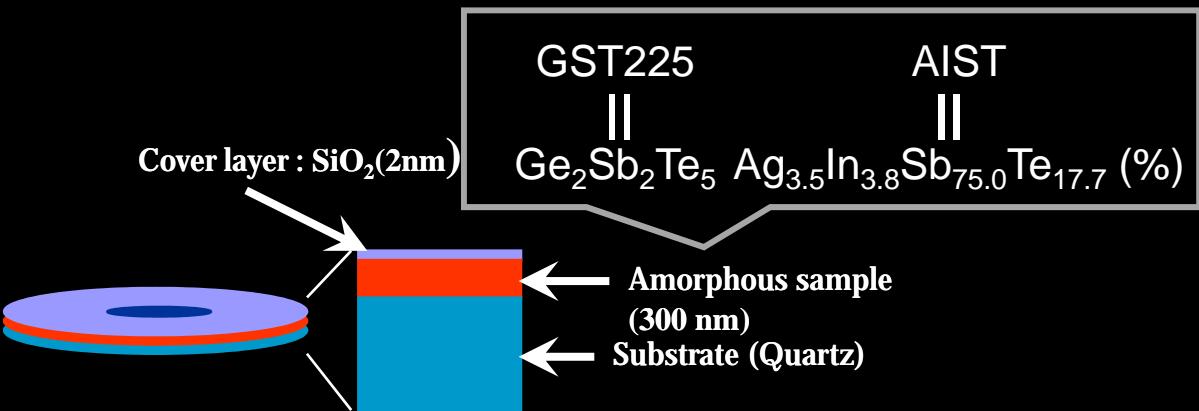
Measurement technique for non-reversible process



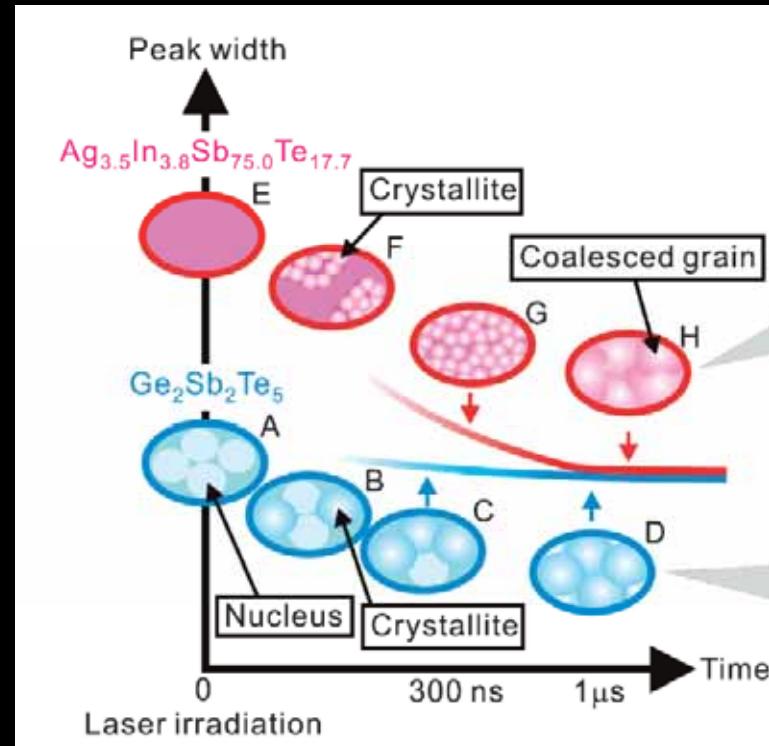
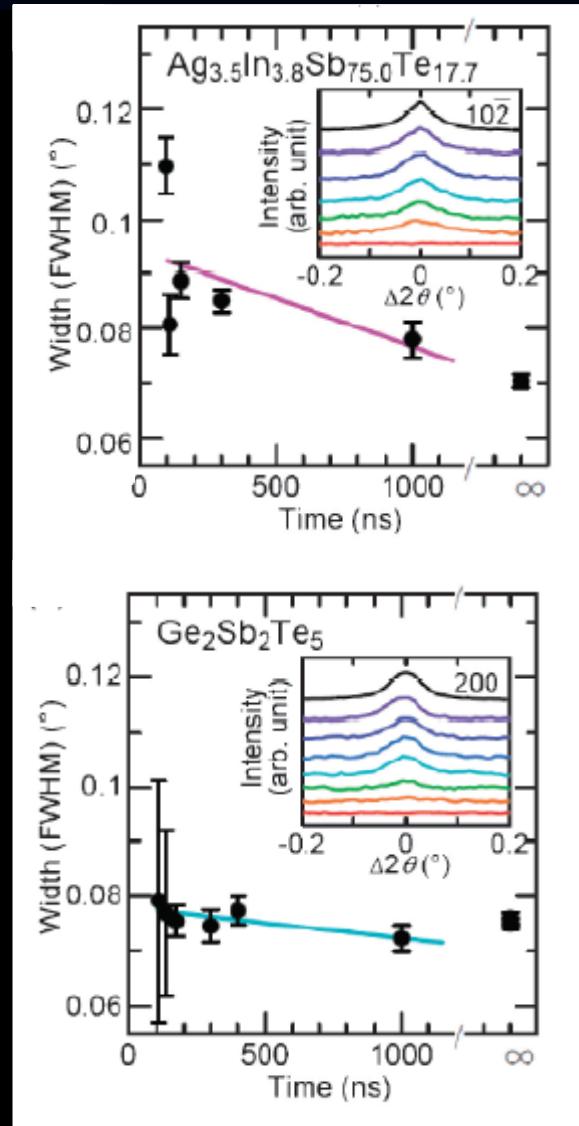
Sample is prepared on the rotating disk, so that the laser pulse always irradiates the fresh sample surface before transition.



Measurement (MCS & Pump-Probe)



Results and discussion



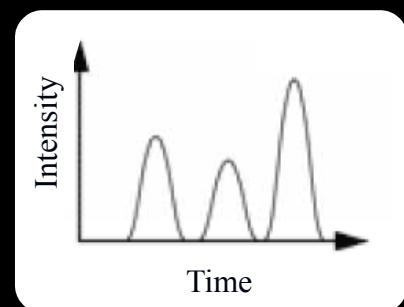
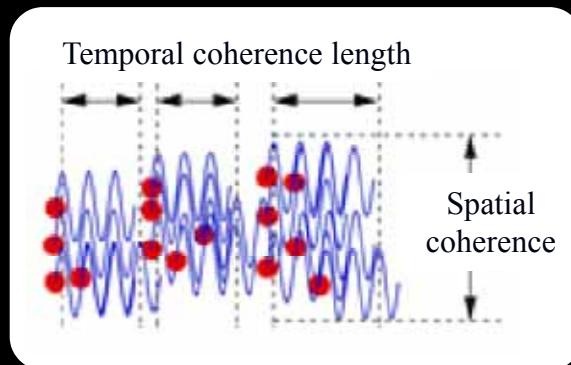
Different crystallization process

Applied Physics Express, 1, 045001 (2008).
Published in March 14.

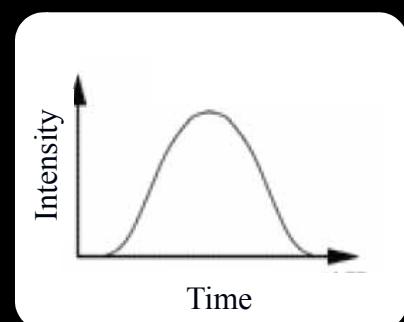
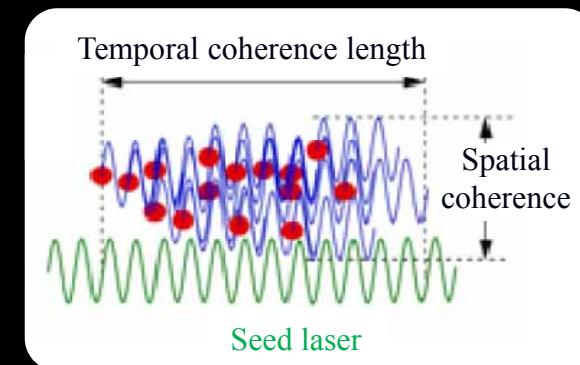
3.3. Laser seeding in FEL

Improving the temporal coherence in single-pass FEL

SASE (Self-Amplified Spontaneous Emission)



Laser-Seeded SASE

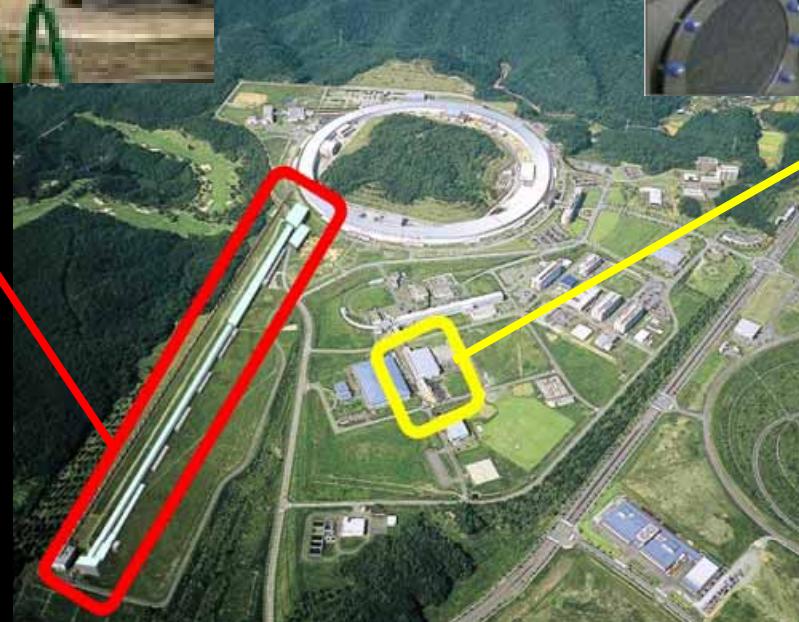


SCSS project in SPring-8

SCSS-XFEL

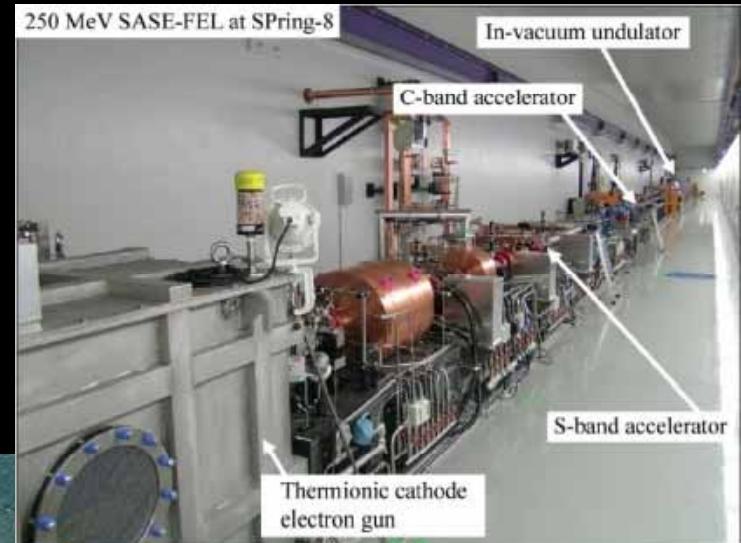


Under
construction

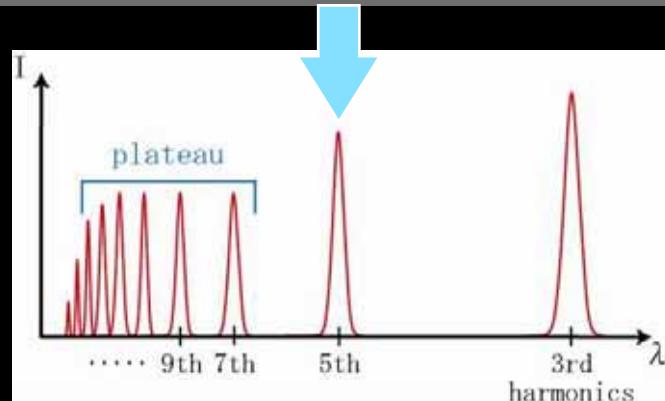


SPring-8 Campus

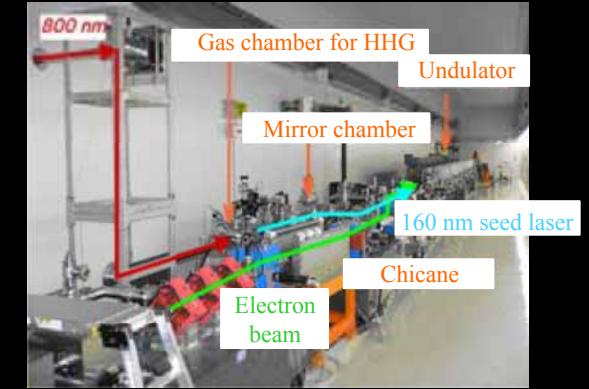
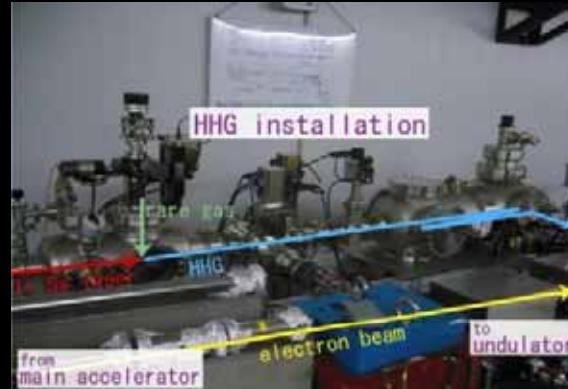
SCSS prototype accelerator



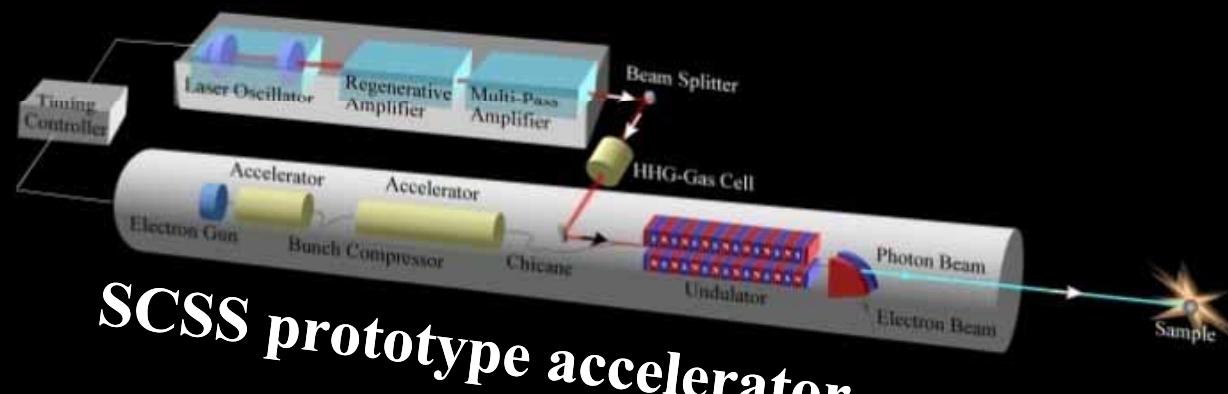
Seeding with Higher Harmonic Generation in Gas



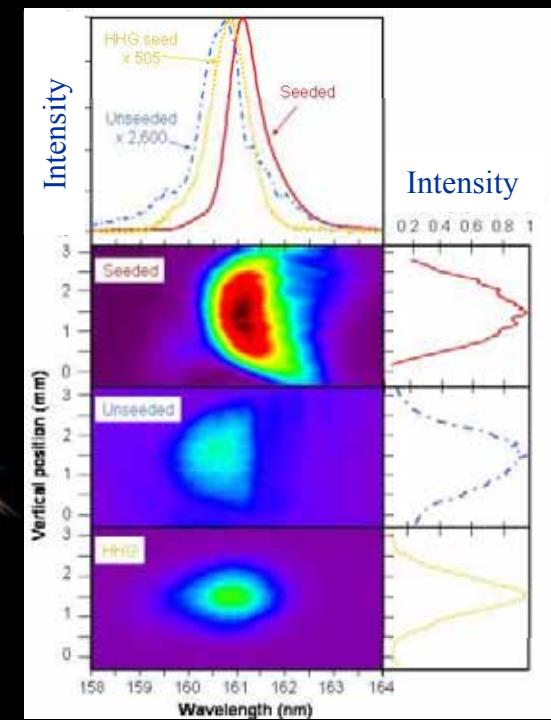
HHG



Demonstration in 160 nm

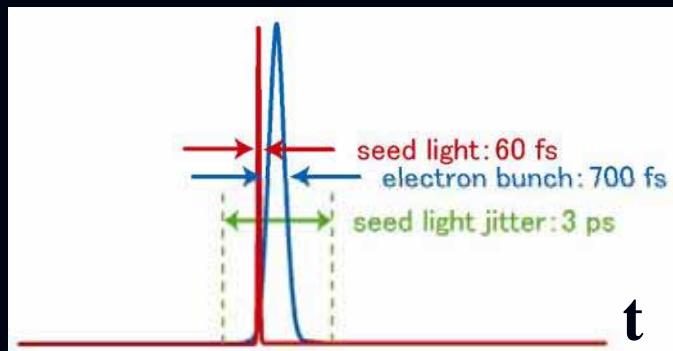


SCSS prototype accelerator

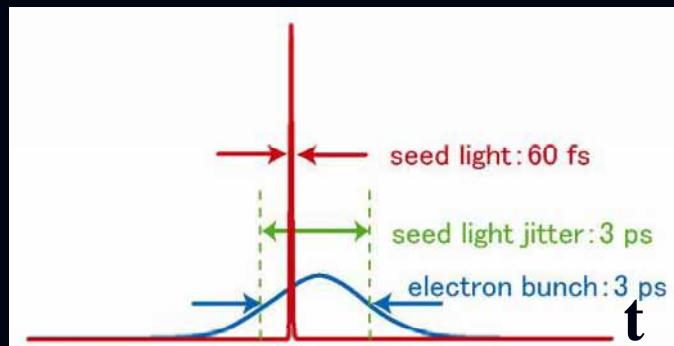


Nature Physics, Online published in March 9

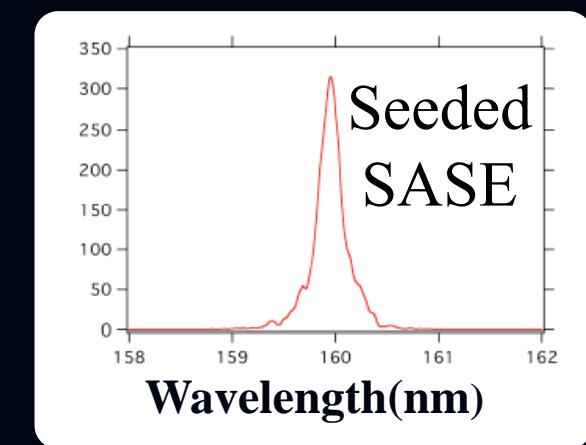
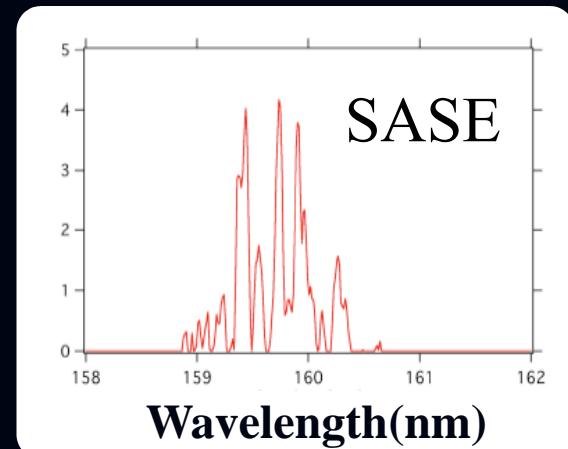
Debunching for stable temporal overlap



Debunching
operation



Stable seeding



Seeded SASE pulse should perfectly be synchronized to the seed laser



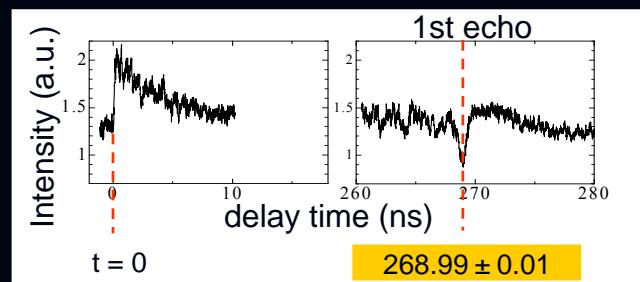
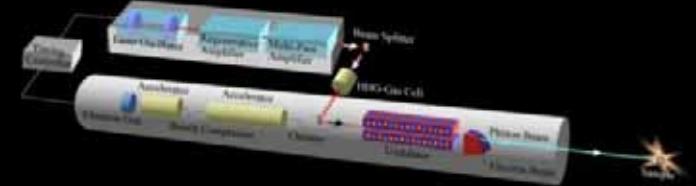
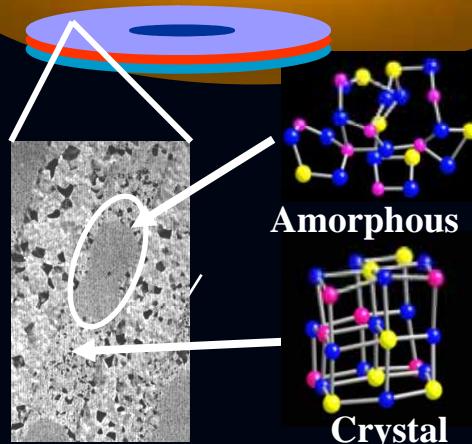
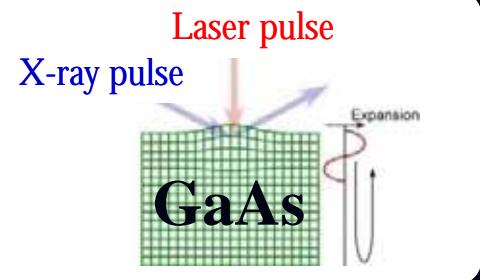
Seed laser pump- seeded SASE probe in femtosecond resolution

4. Summary of Exps with TR technique in SP8

Acoustic echo
in semiconductors

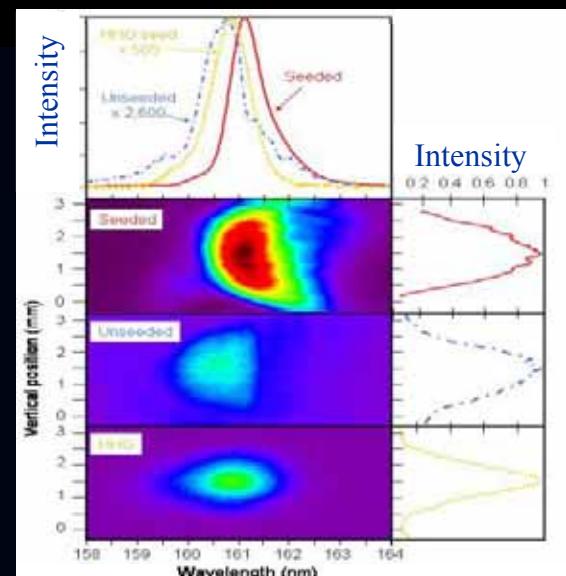
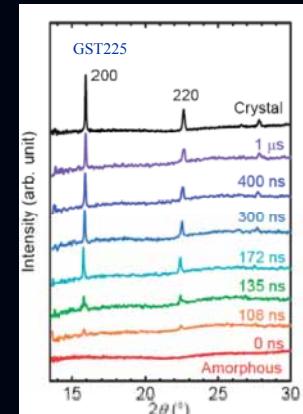
Phase change
in DVD media

Laser seeding
in FEL



Phys. Rev. Lett. 96 (2006) 115505.
Rev. Sci. Instrum. Accepted on March 17.

Applied Physics Express,
1 (2008) 045001.
Published on March 14.



Nature Physics, (2008),
Online published on March 9,
DOI: 10.1038/nphys88989

Future prospective on technical development

- Combination system with fs lasers in SP8

- 40 ps resolution
- Wide time range
- 5 ps synchronization precision
- For non-reversible phenomena

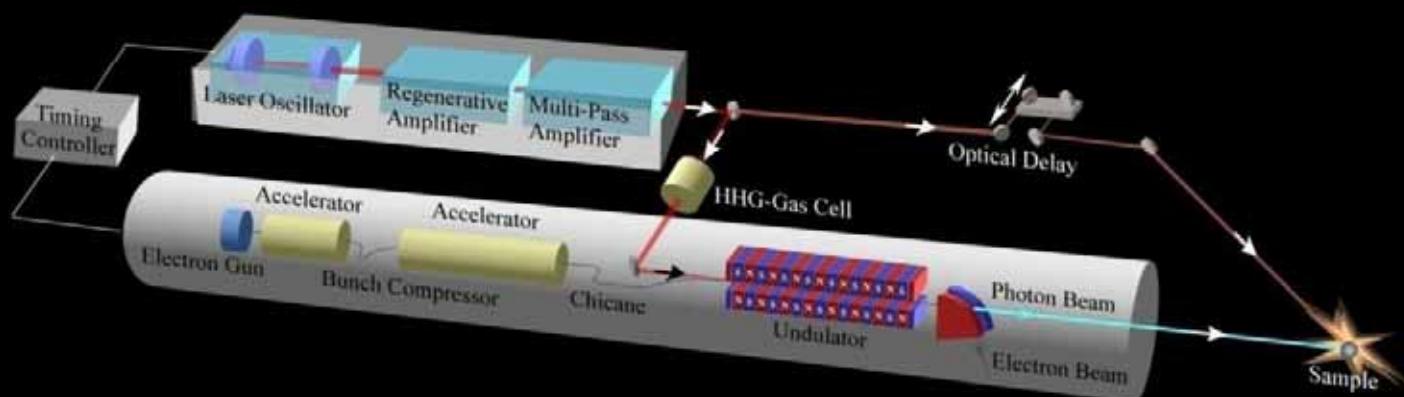


↓ ps to fs

- Femtosecond resolution
- Post processing
- Jitter free system ?

↓ High rep. rate

- Combination with X-ray microbeam
- High repetition rate



Thank you

**Acoustic pulse echoes
in Semiconductors**

Laser Seeding in FEL

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**Phase change
in DVD media**